



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

May 13, 2026	
IGI Report Number	LG800670924
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUSHION MODIFIED BRILLIANT
Measurements	8.13 X 5.88 X 3.91 MM

GRADING RESULTS

Carat Weight	1.47 CARAT
Color Grade	F
Clarity Grade	VVS 2

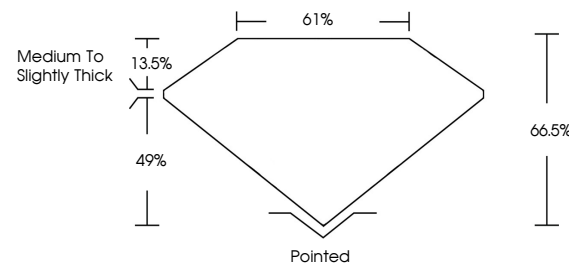
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG800670924

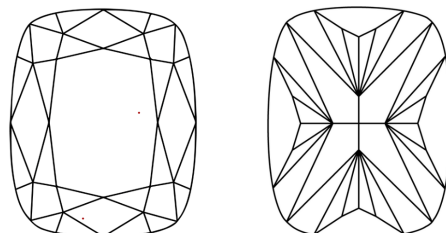
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG800670924
Report verification at lgi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

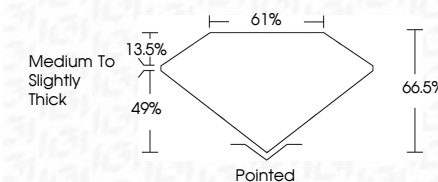
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

May 13, 2026
GI Report No LG800670924
VISION MODIFIED BRILLIANT

1.47 CARAT

F

VVS 2

66.5%

61%

Medium to Slightly Thick

Pointed

EXCELLENT

EXCELLENT

NONE

4081 | Gsmcnc77024

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This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Yves Ilin